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OGOSH25USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#4/B

In re the Application of:	)	
	)	Examiner:
Yuichiro Shindo et al.	)	
	)	Group Art Unit:
Application No.:	)	
	)	
Corresponding International Filing No.:	)	
PCT/JP2003/010251	)	
	)	
Filed: Herewith	)	
	)	
For: HIGH PURITY COPPER	)	
SULFATE AND METHOD	)	
FOR PRODUCTION THEREOF	)	

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SECOND PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified patent application as follows.

**Amendments to the Specification** begin on page two of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page three of this paper.

**Remarks** begin on page seven of this paper.